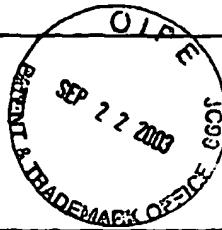


INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Sheet 1 of 6
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Application Number: 10/646,533
 Filing Date: August 22, 2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 008401 02



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	US-3,109,100	10-29-1963	GECEWICZ	250	219	05-19-1960
	US-3,576,685	04-27-1971	SWANN ET AL.	148	187	03-15-1968
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	US-4,382,099	05-03-1983	LEGGE ET AL.	427	34	10-26-1981
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JC	Zhang, B.C., and Cross, R.C., "A high power radio frequency transformer for plasma production," <i>Rev. Sci. Instrum.</i> , Vol. 69, No. 1, pp. 101-108, January 1998.
JC	U.S. Patent Application Serial No.: 09/638,075, filed August 11, 2000, entitled, "EXTERNALLY EXCITED TORROIDAL PLASMA SOURCE," By Hiroji Hanawa, et al.

Examiner's Signature: /Jack Chen/ (08/06/2006)

08/06/2006

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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Sheet 2 of 6	

Application Number: 10/646,533
 Filing Date: August 22, 2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 008401 02

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	US-4,500,563	02-19-1985	ELLENBERGER ET AL.	427	38	12-15-1982
	US-4,521,441	06-04-1985	FLOWERS	427	38	12-19-1983
	US-4,539,217	09-03-1985	FARLEY	427	10	06-27-1984
	US-4,565,588	01-21-1986	SEKI ET AL.	148	186	10-10-1984
	US-4,698,104	10-06-1987	BARKER ET AL.	437	141	03-02-1987
	US-4,764,394	08-16-1988	CONRAD	427	38	01-20-1987
	US-4,778,561	10-18-1988	GHANBARI	156	643	10-30-1987
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	US-4,871,421	10-03-1989	OGLE ET AL.	156	643	09-15-1988
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	US-4,948,458	08-14-1990	OGLE	156	643	08-14-1990
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	JP 59-86214	18.5.1984	JAPAN	UNKNOWN	NO
	JP 62-120041	1.6.1987	JAPAN	UNKNOWN	NO
JC	WO 93/18201	16.09.2003	WIPO	FELCH ET AL.	N/A

Examiner Initials	NON PATENT LITERATURE DOCUMENTS			

Examiner's Signature: /Jack Chen/ (08/06/2006)	Date Considered: 08/06/2006
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DISCLOSURE
STATEMENT BY APPLICANT

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Application Number: 10/646,533
 Filing Date: August 22, 2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 008401 02

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
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	US-5,107,201	04-21-1992	OGLE	324	72.5	12-11-1990
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	US-5,277,751	01-11-1994	OGLE	156	643	06-18-1992
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	US-5,435,881	07-25-1995	OGLE	156	345	03-17-1994
	US-5,505,780	04-09-1996	DALVIE ET AL.	118	723	03-18-1992
	US-5,514,603	05-07-1996	SATO	437	16	05-06-1994
	US-5,520,209	05-28-1996	GOINS ET AL.	137	246	12-03-1993
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	US-5,561,072	10-01-1996	SAITO	437	24	11-21-1994
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Examiner's Signature: /Jack Chen/ (08/06/2006)

Date Considered: 08/06/2006

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Sheet 4 of 6
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Application Number: 10/646,533
 Filing Date: August 22, 2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 008401 02



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INFORMATION DISCLOSURE STATEMENT BY APPLICANT	
Sheet 5 of 6	

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 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 008401 02



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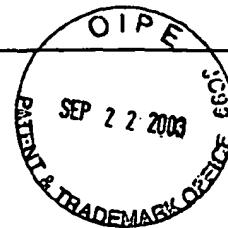
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Examiner's Signature: /Jack Chen/ (08/06/2006)	Date Considered: 08/06/2006
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Sheet 6 of 6
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Application Number: 10/646,533
 Filing Date: August 22, 2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 008401 02



U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
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Examiner Initials	Foreign Patent Document	Publication Date	Country	Name of Patentee or Applicant of Cited Document	Translation? (Yes/No/n/a)

Examiner's Signature: /Jack Chen/ (08/06/2006) Date Considered: 08/06/2006

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INFORMATION
DISCLOSURE
STATEMENT BY APPLICANT

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Application Number: 10/646,533
 Filing Date: August 22, 2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket Number: 6915 P02

U. S. PATENT DOCUMENTS

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Examiner's Signature:	/Jack Chen/ (08/06/2006)	Date Considered:
		08/06/2006

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number: 10/646,533 Filing Date: August 22, 2003 First Named Inventor: Kenneth COLLINS, et al. Group Art Unit: 1763 Examiner Name: Unknown Attorney Docket Number: 6915 P02
Sheet 1 of 1 		

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
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Examiner's Signature: /Jack Chen/ (08/06/2006)	Date Considered: 08/06/2006
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STATEMENT BY APPLICANT

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Application Number: 10/646,533
Filing Date: August 22, 2003
First Named Inventor: Kenneth COLLINS, et al.
Group Art Unit: 1763
Examiner Name: Unknown
Attorney Docket Number: 006915 P02

U. S. PATENT DOCUMENTS

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	US-6,000,360	12-14-1990	KOSHIMUZU	118	723	07-02-1997
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DISCLOSURE
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MAY 26 2005

Application Number: 10/646,533
Filing Date: August 22, 2003
First Named Inventor: Kenneth Collins, et al.
Group Art Unit: 2813
Examiner Name: Jack S. Chen
Attorney Docket Number: 006915 P02

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Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
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	US-6,101,971	08-15-2000	DENHOLM ET AL.	118	723E	08-15-2000
	US-6,139,697	10-31-2000	CHEN ET AL.	204	192.15	01-31-1997
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	US-6,811,448	11-02-2004	PATON ET AL.	439	706	07-15-2003
JC	US-6,838,695	01-04-2005	DORIS ET AL.	257	55	11-25-2002

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Examiner's Signature: /Jack Chen/ (08/06/2006)

Date Considered: 08/06/2006

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Application Number: 10/646,533
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 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: 2813
 Examiner Name: Jack S. Chen
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Examiner's Signature: /Jack Chen/ (08/06/2006)	Date Considered: 08/06/2006
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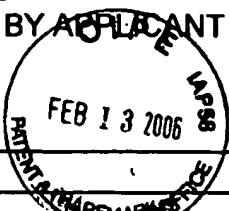
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INFORMATION

DISCLOSURE

STATEMENT BY APPLICANT

Sheet 1 of 1



Application Number: 10/646,533
 Filing Date: 08/22/2003
 First Named Inventor: Kenneth COLLINS, et al.
 Group Art Unit: 2813
 Examiner Name: Jack S. Chen
 Attorney Docket Number: 006915/P02

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Date Considered: 08/06/2006

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